



**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hideki KOMATSUDA et al.

Batch No.: D42

Allowed: March 13, 2001

Group Art Unit: 2882

Application No.: 09/396,582

Examiner: C. Church

Filed: September 15, 1999

Docket No.: 105203

For: EXPOSURE APPARATUS AND EXPOSURE METHOD USING SAME

5'12  
7-19-01  
C. Church

**LETTER TO THE OFFICIAL DRAFTSPERSON**

Director of the U.S. Patent and Trademark Office  
Washington, D.C. 20231

Sir:

Please substitute the attached 2 sheets of formal drawings depicting Figures 1 and 2  
for the corresponding drawings filed with the application.

Respectfully submitted,

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Date: April 12, 2001

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